

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Branco et al.

Serial No.: 09/617,454 ✓

Group Art Unit: 1746

Filed: July 17, 2000 ✓

Examiner: Markoff, A.

Title: Method for Cleaning Plasma Etch
Chamber Structures ✓

Attorney Docket No.: CY-0015

RESPONSE TO FINAL OFFICE ACTION

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Commissioner for Patents
P.O. Box 1450
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A. Introductory Comments

The following is submitted in response to the FINAL Office Action dated June 3, 2003.
The two month Advisory Action period ends August 4, 2003.

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37 C.F.R. 81.8

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